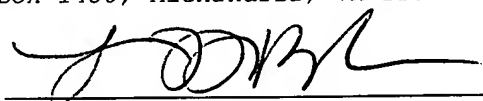




PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Signature

Appl No. : 10/090,915 Confirmation No. 7688
Applicant : Konstantin Holdermann
Filed : March 5, 2002
Title : ETCHING SOLUTION FOR WET CHEMICAL PYRAMIDAL TEXTURE
ETCHING OF SILICON SURFACES
TC/A.U. : 1765
Examiner : Shamim Ahmed
Docket No. : 47585/RAG/S969
Customer No. : 23363

COMMENTS ON REASONS FOR ALLOWANCE

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December 2, 2004

Commissioner:

The Applicant believes the Examiner's stated reasons for allowance are unnecessary. The record as a whole makes clear the reasons for allowance and therefore a statement by the Examiner is not necessary or warranted. While the Applicant agrees that the claims are allowable, the Applicant does not acquiesce in the stated reasons for allowance, nor that patentability requires each stated feature as expressed by the Examiner.

Respectfully submitted,

CHRISTIE, PARKER & HALE, LLP

By 
Robert A. Green
Reg. No. 28,301
626/795-9900

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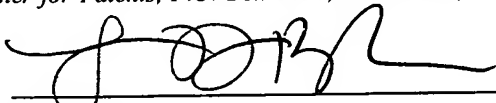


PATENT

Date of Notice
of Allowance : September 15, 2004

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Signature

Applicant : Konstantin Holdermann Confirmation No. 7688
Application No. : 10/090,915
Filed : March 5, 2002
Title : ETCHING SOLUTION FOR WET CHEMICAL PYRAMIDAL
TEXTURE ETCHING OF SILICON SURFACES

Grp./Div. : 1765
Examiner : Shamim Ahmed

Docket No. : 47585/RAG/S969

STATEMENT OF THE SUBSTANCE OF TELEPHONIC INTERVIEW

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Commissioner:

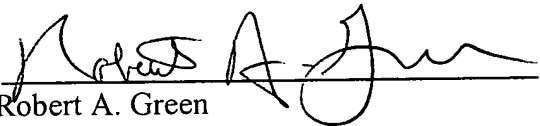
Applicant would like to thank the Examiner for taking the time to conduct a telephonic interview with applicant's representative on September 3, 2004. During that interview, an agreement was reached regarding certain amendments to the pending claims. Specifically, applicant authorized the Examiner's amendment of claims 1 and 7 in the following manner:

1. A free-standing silicon etching solution for ~~[the]~~ wet chemical pyramidal texture etching ~~[of silicon surfaces]~~ comprising: water, an alkaline reagent, isopropanol and aqueous alkaline ethylene glycol.

Appln No. 10/090,915
Stmnt date December 2, 2004

7. A free-standing silicon etching solution for ~~the~~ wet chemical pyramidal texture etching ~~[of silicon surfaces]~~ comprising: water, sodium or potassium hydroxide, isopropanol and aqueous alkaline ethylene glycol.

Respectfully submitted,
CHRISTIE, PARKER & HALE, LLP

By 
Robert A. Green
Reg. No. 28,301
626/795-9900

RAG/les

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